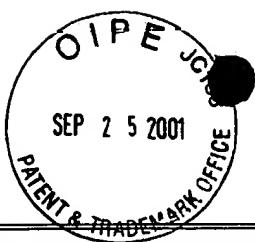


Form PTO-1449 (Modified)			Atty. Docket No. <i>#4</i>	Serial No. 09/904,634			
LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)			Applicants: Ami CHAND; Kevin KJOLLER; Kenneth BABCOCK and Michael HARRIS				
O I P E P A T E N T T O M E N T O R Y O F F I C E S E P 2 5 2001 PTO CUSTOMER NO. 023907			Filing Date: 07/13/2001		Group: 2858 2856		
REFERENCE DESIGNATION			U.S. PATENT DOCUMENTS				
Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
<i>Dan</i>		6,189,374B1	02/2001	ADDERTON, et al.	—	—	
<i>Dan</i>		6,181,097B1	01/2001	LI, et al.	318	592	
<i>Dan</i>		6,057,546	05/2000	BRAUNSTEIN, et al.	250	306	
<i>Dan</i>		6,038,916	03/2000	CLEVELAND, et al.	—	—	
<i>Dan</i>		5,831,181	11/1998	MAJUMDAR, et al.	73	105	
<i>Dan</i>		5,512,808	04/1996	CLARK, JR., et al.	—	—	
<i>Dan</i>		5,504,338	04/1996	MARIAN, et al.	250	306	
<i>Dan</i>		5,461,907	10/1995	TENCH, et al.	73	105	
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Subclass	Translation
							Yes
							No
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)							
<i>Dan</i>		Atomic Force Microscopy Using An Integrated Comb-Shape Electrostatic Actuator For High-Speed Feedback Motion, T, Akiyama, et al., <i>Applied Physics Letters</i> , Vol. 76, No. 21, 05/22/2000, pgs. 3139-3141					
<i>Dan</i>		Controlled Manipulation Of Molecular Samples With The NanoManipulator, Martin Guthold, et al., <i>IEEE/ASME Transactions On Mechatronics</i> , Vol. 5, No. 2, June 2000, pgs. 189-198					
<i>Dan</i>		Nanoparticle Manipulation By Mechanical Pushing: Underlying Phenomena And Real-Time Monitoring, C. Baur, et al., <i>Foresight Institute Web Page</i> , 3 pgs.					
<i>Dan</i>		Manipulation Of Gold Nanoparticles In Liquid Environments Using Scanning Force Microscopy, R. Resch, et al., <i>Elsevier Ultramicroscopy 82</i> (2000), pgs. 135-139					
EXAMINER <i>Dan</i>		DATE CONSIDERED <i>30 Aug 2003</i>					
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

Form PTO-1449 (Modified)			Atty. Docket No.	Serial No.			
LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)			1067.066	09/904,634			
SEP 25 2001 PATENT & TRADEMARK OFFICE U.S. GOVERNMENT			Applicants: Ami CHAND; Kevin KJOLLER; Kenneth BABCOCK and Michael HARRIS				
PTO CUSTOMER NO. 023907			Filing Date: 07/13/2001		Group: 2878 2856		
REFERENCE DESIGNATION			U.S. PATENT DOCUMENTS				
Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
Dm		5,365,073	11/1994	White	—	—	
Dm		5,252,835	10/1993	LIEBER, et al.	250	492.1	
Dm		5,077,473	12/1991	ELINGS, et al.	—	—	
Dm		4,987,312	01/1991	EIGLER	—	—	
Dm		4,943,719	07/1990	AKAMINE, et al.	—	—	
Dm		4,878,213	10/1989	KAZAN, et al.	—	—	
Dm		4,539,089	09/1985	BINNIG, et al.	—	—	
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Subclass	Translation
							Yes
							No
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)							
Dm		Microfabricated Tweezers With A Large Gripping Force And A Large Range Of Motion, Thesis by Wen-Hwa Chu, Phd Degree, Dept. of Elec. Engineering & Applied Physics CWRU, August 1994, 2 pgs.					
Dm		3 rd Tech NanoManipulator DP-100 Functional Overview v1.0, 9/11/00, 12 pgs.					
Dm		Nanotube Nanotweezers, Philip Kim and Charles M. Lieber, <i>Science</i> , Vol 286, 12/10/1999, pgs. 2148-2150					
Dm		Pearls Found On The Way To Ideal Interface For Scanned-Probe Microscopes, Russell M. Taylor, et al., <i>Published in the proceedings of the IEEE Visualization 1997 Conference</i> , 6 pgs.					
EXAMINER	<i>CJS 2</i>		DATE CONSIDERED <i>30 Jun 2003</i>				
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							



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PTO CUSTOMER NO. 023907		Applicants: Ami CHAND; Kevin KJOLLER; Kenneth BABCOCK and Michael HARRIS					
		Filing Date: 07/13/2001		Group: 2858 2856			
REFERENCE DESIGNATION		U.S. PATENT DOCUMENTS					
Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Subclass	Translation
							Yes
							No
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)							
<i>Dn</i>		Selective Chemical Vapor Deposition Of Tungsten For Microelectromechanical Structures, N. C. Macdonald, et al., <i>Sensors and Actuators</i> , 20 (1989), pgs. 123-133					
<i>Dn</i>		Silicon-Processed Overhanging Microgripper, Chang-Jin, Kim, et al., <i>Journal Of Microelectromechanical Systems</i> , Vol. 1, No. 1, March 1992, 6 pgs.					
<i>Dn</i>		Simulation Methods For Micro-Electro-Mechanical Structures (MEMS) With Application To A Microtweezer, F. Shi, et al., <i>Pergamon Computers & Structures</i> , Vol. 56, No. 5, 1995, pgs. 769-783					
<i>Dn</i>		Nanotechnology: Tweezers For The Nanotool Kit, Chad A. Mirkin, <i>Science Magazine Web Site</i> , sss.stke.org, 03/12/01, 3 pgs.					
<i>Dn</i>		Twin-Probe Scanning Tunneling Microscope, Shigemi Tsukamoto, et al., <i>Rev. Sci. Instrum.</i> 62 (7), July 1991, pgs. 1767-1771					
EXAMINER <i>Ols. S.</i>		DATE CONSIDERED <i>30 June 2003</i>					
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

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